FORM PTO-1449 (Modified)

U.S. Department of Commerce Patent and Trademark Office

Attorney Docket No.: COOL-01500

Serial No.: 10/643,638

Applicants: Peng Zhou et al

INFORMATION DISCLOSSES STATEMENT BY APPLICANT Sheets If Necessary) Filing Date: August 18, 2003 Group Art Unit: 3753 (37 CFR § 1.98(b)) **U.S. PATENT DOCUMENTS** Serial / Patent Number Examiner Initials Issue Date Applicant / Patentee Class Subclass Filing Date FZ 01/12/93 361 385 04/02/91 5,179,500 Koubek et al. A۸ ΑB AC ΑD ΑE ΑF ΑG ΑH Αl ΑJ ΑK ΑL AM AN ΑO ΑP AQ AR AS ΑŤ ΑU ΑV ΑW ΑX ΑY ΑZ ВА ВВ вс BD BE BF BG вн Philip Zec 1/26/2005 Date Considered: Examiner: EXAMINER:

Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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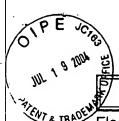
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets if Necessary)

Applicants: Peng Zhou et al

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xaminer Initials		Serial / Patent Number	Issue Date	Applicant / Patentee	Class	Subclass	Filing Date
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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention BOILING TEMPERATURE DESIGN IN PUMPED MICROCHANNEL COOLING LOOPS

Application Number:

10/643638

Confirmation Number:

4432

First Named Applicant:

Peng Zhou

Attorney Docket Number:

Search string:

(3948316 or 5161089 or 5228502 or 5239443

or 5265670 or 5978220 or 5993750 or

6729383).pn.

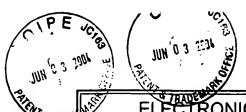
US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
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Signature

Examiner Name	Date
Pilip Zec	1/26/2005



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention

BOILING TEMPERATURE DESIGN IN PUMPED MICROCHANNEL COOLING LOOPS

Application Number:

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First Named Applicant:

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Attorney Docket Number:

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(4467861 or 4903761 or 5016090 or 5269372 or 5275237 or 5310440 or 5346000 or 5388635 or 5945217 or 6019165 or 6034872 or 6039114 or 6253832 or 6257320 or 6330907 or 6336497 or 6366462 or 6367544 or 6431260 or 6466442 or 6519151 or 6533029 or 6536516 or 6601643

or 6609560 or 6651735 or 20030213580).pn.

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Note: Applicant is not required to submit a paper copy of cited US Published Applications

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FZ	1	20030213580	2003-11-20	Philpott et al.	A1		

Signature

Examiner Name	Date
Pilip Zec	1/26/2005

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§ 1.98(b)) Group Art Unit: 3753 Filing Date: August 18, 2003 (37 CFR § 1.98(b)) FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS Translation Document **Publication Date** Country / Patent Office Class Subclass Number Yes No FZ 97212126.9 03/04/97 CN BOID 61/42 Х AA F7 Х 2000-277540 10/06/00 HOIL 21/50 AR OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication) Stephen C. Jacobson et al., "Fused Quartz Substrates for Microchip Electrophoresis", Analytical Chemistry, Vo. 67, No. 13, July 1, 1995, pages 2059-2063. FZ AC ΑĎ Kendra V. Sharp et al., "Liquid Flows in Microchannels", 2002, Vol. 6, pages 6-1 to 6-38. Shuchi Shoji et al., "Microflow devices and systems", J. Microcech. Microeng. 4 (1994), pages 157-171, printed in the U.K. ΑE Angela Rasmussen et al., "Fabrication Techniques to Realize CMOS-Compatible Microfluidic Microchannels", Journal of Microelectromechanical, Vo. 10, No. 2, June 2001, pages 286-297. ΑF J. H. Wang et al., "Thermal-Hydraulic Characteristic of Micro Heat Exchangers", 1991, DSC-Vol. 32, Micromechanical Sensors, Actuators, and Systems, pages 331-339. ΑG Gad Hetsroni et al., "Nonuniform Temperature Distribution in Electronic Devices Cooled by Flow in Parallel Microchannels", IEEE Transactions on Components and Packaging Technologies, March 2001, Vol. 24, No. 1, pages 16-23. AH X. F. Peng et al., "Heat Transfer Characteristics of Water Flowing through Microchannels", Experimental Heat Transfer An International Journal, Vol. 7, No. 4, October-December 1994, pages 265-283. ΑI Linan Jiang et al., "Forced Convection Boiling in a Microchannel Heat Sink", Journal of Microelectromechanical Systems, Vol. 10, No. 1, March 2001, pages 80-87. AJ Muhammad M. Rahman et al., "Experimental Measurements of Fluid Flow and Heat Transfer in Microchannel Cooling Passages in a Chip Substrate", 1993, EEP-Vol. 4-2, Advances in Electronic Packages, pages 685-692. ΑK X. F. Peng et al., "Forced convection and flow boiling heat transfer for liquid flowing through Microchannels", 1993, Int. J. Heat Mass Transfer, Vol. 36, NO. 14, pages 3421-3427. AL Lung-Jieh Yang et al., "A Micro Fluidic System of Micro Channels with On-Site Sensors by Silicon Bulk Micromaching", September 1999, Microfluidic Devices and Systems II, Vol. 3877, pages 267-272. AM G. Mohiuddin Mala et al., "Heat transfer and fluid flow in microchannels", 1997, Int. J. Mass transfer, Vol. 40, No. 13, pages 3079-3088, printed in Great Britain. AN J. M. Cuta et al., "Fabrication and Testing of Micro-Channel Heat Exchangers", SPIE Microlithography and Metrology in Micromaching, Vol. 2640, 1995, pages 152-160. AO Linan Jiang et al., "A Micro-Channel Heat Sink with Integrated Temperature Sensors for Phase Transition Study", 1999, 12th IEEE International Conference on Micro Electro Mechanical Systems, pages 159-164. AP Linan Jiang et al., "Fabrication and characterization of a microsystem for a micro-scale heat transfer study", J. Micromech. Microeng. 9 (1999) pages 422-428, printed in the U.K. AQ FZ M. B. Bowers et al., "High flux boiling in low flow rate, low pressure drop mini-channel and micro-channel heat sinks", 1994, Int. J. Heat Mass Transfer, Vol. 37, No. 2, pages 321-332. AR AS Yongendra Joshi, "Heat out of small packages", December 2001, Mechanical Engineer, pages 56-58. A. Rostami et al., "Liquid Flow and Heat Transfer in Microchannels: a Review", 2000, Heat and Technology, Vol. 18, No. 2, pages 59-68. AT Lian Zhang et al., "Measurements and Modeling of Two-Phase Flow in Microchannels with Nearly Constant Heat Flux Boundary Conditions", Journal of Microelectromechanical Systems, Vol.11, No. 1, February 2002, pages 12-19. AU Muhammad Mustafizur Rahman, "Measurements of Heat Transfer in Microchannel Heat Sinks", Int. Comm. Heat Mass Transfer, Vol. 27, No. ΑV 4, May 2000, pages 495-506. Issam Mudawar et al., "Enhancement of Critical Heat Flux from High Power Microelectronic Heat Sources in a Flow Channel", Journal of Electronic Packaging, September 1990, Vol. 112, pages 241-248. AW Nelson Kuan, "Experimental Evaluation of Micro Heat Exchangers Fabricated in Silicon", 1996, HTD-Vol. 331, National Heat Transfer Conference, Vol. 9, pages 131-136. AX E. W. Kreutz et al., "Simulation of micro-channel heat sinks for optoelectronic microsystems", Microelectronics Journal 31(2000) pages 787-790. AY J. C. Y. Koh et al., "Heat Transfer of Microstructure for Integrated Circuits", 1986, Int. Comm. Heat Mass Transfer, Vol. 13, pages 89-98. ΑZ Snezana Konecni et al., "Convection Cooling of Microelectronic Chips", 1992, InterSociety Conference on Thermal Phenomena, pages 138-144. RA

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1/26/2005 Date Considered:

initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 2 of 7

FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office Serial No.: 10/643,638 Attorney Docket No.: COOL-01500 (Modified) INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary) Applicants: Peng Zhou et al. Group Art Unit: 3753 Filing Date: August 18, 2003 (37 CFR § 1.98(b)) OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication) Michael B. Kleiner et al., "High Performance Forced Air Cooling Scheme Employing Microchannel Heat Exchangers", 1995, IEEE Transactions on Components, Packaging, and Manufacturing Technology-Part A, Vol. 18, No. 4, pages 795-804. F Z RR Jerry K. Keska Ph. D. et al., "An Experimental Study on an Enhanced Microchannel Heat Sink for Microelectronics Applications", EEP-Vol. 26-2, Advances in Electronic Packaging, 1999, Vol. 2, pages 1235-1259. 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Sheet 3 of 7

FORM PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office	Attorney Docket No.: COOL-01500	Serial No.: 10/643,638		
	ORMATIC	ON DISCLOSURE STATEMENT BY APPLICANT	Applicants: Peng Zhou et al.			
(37 CFR § 1.9	8(ъ))	(Use Several Sheets If Necessary)	Filing Date: August 18, 2003	Group Art Unit: 3753		
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Attorney Docket No.: COOL-01500 FORM PTO-1449 U.S. Department of Commerce Serial No.: 10/643,638 (Modified) Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary) Applicants: Peng Zhou et al. Group Art Unit: 3753 Filing Date: August 18, 2003 (37 CFR § 1.98(b)) OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication) 172 George M. Harpole et al., MICRO-CHANNEL HEAT EXCHANGER OPTIMIZATION, 1991, Seventh IEEE SEMI-THERM Symposium, FH pages59-63. Pei-Xue Jiang et al., Thermal-hydraulic performance of small scale micro-channel and prous-media heat-exchangers, 2001, International Journal of Heat and Mass Transfer 44 (2001), pages 1039-1051. EI X.N. Jiang et al., Laminar Flow Through Microchannels Used for Microscale Cooling Systems, 1997, IEEE/CPMT Electronic Packaging Technology Conference, pages 119-122, Singapore. 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